

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 89518
 CHEN, Hui-Mei, et al. : Confirmation Number: 3341
 Application No.: 10/786,807 : Group Art Unit: 2822
 Filed: February 25, 2004 : Examiner: AU, Bac H.
 For: METHOD FOR IMPROVING SEMICONDUCTOR WAFER TEST ACCURACY

TRANSMITTAL

Mail Stop RCE
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is a Request For Continued Examination and an Amendment, including a Petition For Extension of Time, in the above-identified application.

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	8	20	0	\$52.00 =	\$0.00
Independent Claims	3	3	0	\$220.00 =	\$0.00
Fee for extension of time					\$130.00
Request for Continued Examination (RCE)					\$810.00
Total of Above Calculations					\$940.00

- ☒ Please charge my Deposit Account No. 502624 in the amount of \$940.00.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 502624, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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Date: August 1, 2011

**Please recognize our Customer No. 89518 as our
 correspondence address.**